

<b>Notice of References Cited</b>		Application/Control No. 10/820,159	Applicant(s)/Patent Under Reexamination TAKEBE ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0143129	07-2003	Rabellino et al.	422/171
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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